



Sheet 1 of 1

Form 1449*	Atty. Docket No.: 303.537US1	Serial No. 09/145,595
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)	Applicant: Ji Ung Lee	
	Filing Date: September 2, 1998	Group: 2811

U.S. PATENT DOCUMENTS

**Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date
						If Appropriate
K G	5,229,331	07/20/1993	Doan, T.T., et al.	437	228	02/14/92

FOREIGN PATENT DOCUMENTS

**Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No

OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

**Examiner Initial	
K G	Ting, C.Y., "Study of planarized sputter-deposited SiO ₂ ", J. Vac. Sci. Technol., 15(3), pgs. 1105-1112, (May/June 1978)

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*Substitute Disclosure Statement Form (PTO-1449)

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